

## ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

### Title of Invention

OXIDATION METHOD FOR ALTERING A FILM STRUCTURE  
AND CMOS TRANSISTOR STRUCTURE FORMED THEREWITH

Application Number :

Confirmation Number:

First Named Applicant: Michael Belyansky

Attorney Docket Number: FIS920030286US1

Art Unit:

Examiner:

Search string: ( 5847419 or 6316820 or 6504235 or 6538278 or 20020197803 ).pn

### US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

| init | Cite.No. | Patent No. | Date       | Patentee        | Kind | Class | Subclass |
|------|----------|------------|------------|-----------------|------|-------|----------|
|      | 1        | 5847419    | 1998-12-08 | Imai, et al.    |      |       |          |
|      | 2        | 6316820    | 2001-11-13 | Schmitz, et al. |      |       |          |
|      | 3        | 6504235    | 2003-01-07 | Schmitz, et al. |      |       |          |
|      | 4        | 6538278    | 2003-03-25 | Chau            |      |       |          |

### US Published Applications

**Note: Applicant is not required to submit a paper copy of cited US Published Applications**

| init | Cite.No. | Pub. No.    | Date       | Applicant     | Kind | Class | Subclass |
|------|----------|-------------|------------|---------------|------|-------|----------|
|      | 1        | 20020197803 | 2002-12-26 | Leitz, et al. |      |       |          |

### Signature

|               |      |
|---------------|------|
| Examiner Name | Date |
|               |      |